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PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2800

42700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masuyuki KIKUSHIMA et al.

Group Art Unit: 2834

Application No.: 09/120,806

Examiner: M. Budd

Filed: July 23, 1998

Docket No.: 101151

For: PIEZO-ELECTRIC RESONATOR AND MANUFACTURING METHOD THEREOF

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated January 14, 2000, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claim 8 as follows:

8. (Amended) A piezo-electric resonator comprising:
 a housing having an opening; and
 a piezo-electric resonator element provided in the housing, said housing comprising a first ceramic substrate having a first thickness, and a second ceramic substrate provided with the opening and having a second thickness larger than the first thickness, the second ceramic substrate being laminated on the first ceramic substrate, and an edge portion of the opening and a periphery of the opening being metallized.

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